

10/582343

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

1AP20 Rec'd PCT/PTO

09 JUN 2006

In re the Application of

Philippe ROBERT

Application No.: New U.S. National Stage of PCT/FR2004/003216

Filed: June 9, 2006

Docket No.: 128275

For: MICROCOMPONENT COMPRISING A HERMETICALLY-SEALED MICROCAVITY
AND METHOD FOR PRODUCTION OF SUCH A MICROCOMPONENT

INFORMATION DISCLOSURE STATEMENT

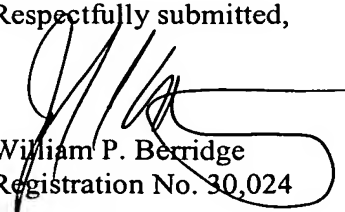
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. One or more reference cited herein was cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information. See References 2-5.
- ☒ 3. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.
- ☒ 4. Reference 1 corresponds to Reference 3.

Respectfully submitted,


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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 128275		APPLICATION NO. New US National Stage of PCT/FR2004/003216 <div style="font-size: 2em; font-weight: bold; position: absolute; top: 10px; right: 10px;">10/582343</div>	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT Philippe ROBERT			
				FILING DATE June 9, 2006			

U.S. PATENT DOCUMENTS				
Examiner Initials	Cite No.	Document Number	Date	Name
	1	5,090,254	2/25/1992	GUCKEL et al.

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Document Number	Date	Country	With English Abstract	With English Translation
	2	DE 100 05 555 A	8/16/2001	GERMANY		
	3	EP 0 451 992 A	10/16/1991	EUROPE		

OTHER DOCUMENTS		
Examiner Initials	Cite No.	(Including Author, Title, Date, Pertinent Pages, etc.)
	4	M. BARTEK et al., "Vacuum sealing of microcavities using metal evaporation," <u>Sensors and Actuators A</u> , vol. 60, no. 1-3, pp. 364-368 (May 1, 1997).
	5	M. FURTSCH et al., "Texture and stress profile in thick polysilicon films suitable for fabrication of microstructures," <u>Thin Solid Films</u> , vol. 296, no. 1-2, pp. 177-180 (March 1, 1997).

EXAMINER	DATE CONSIDERED
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Date: June 9, 2006